

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Bright et al.

Application No: 10/722,729

Filed: November 25, 2003

For: APPARATUS FOR CONTROLLING WAFER
TEMPERATURE IN CHEMICAL MECHANICAL
POLISHING

) Attorney Docket No: LAM2P318C

) Examiner: G.B.M. Nguyen

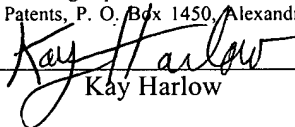
) Group Art Unit: 3723

) Date: August 19, 2005

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on August 19, 2005.

Signed: _____


Kay Harlow

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Letter to Official Draftsperson

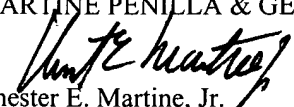
Transmitted herewith are Replacement Sheets 6 of 9 and 7 of 9. Please substitute these Replacement Sheets for the respective as-filed sheets 6 and 7.

Replacement Sheet 6 changes the former "DS" to "D5", as is set forth on page 19, line 7 in reference to Fig. 5A (line 1).

Replacement Sheet 7 adds "D6" to the diameter, as is set forth on page 23, line 11 in reference to Fig. 6A.

Because these changes are based on the original specification, they do not add new matter. It is respectfully requested that these Replacement Sheets 6 of 9 and 7 of 9 be substituted for the respective as-filed sheets 6 and 7.

Respectfully submitted,
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